



Post-Doctoral Research Appointment

Prof. David Hoelzle in the Dept. of Mechanical and Aerospace Engineering at the Ohio State University is seeking applicants for the position of post-doctoral researcher. Prof. Hoelzle runs a research lab with a focus on control systems and dynamics in microscale systems and microscale manufacturing; specific applications include high-throughput measurement of the mechanical properties of cells, tissue engineering, and microscale additive manufacturing.

Details:

Duration: 1 year appointment with the potential for a longer appointment with acquisition of more funding.
Qualifications: PhD in Mechanical, Electrical, or Bio-engineering with significant research background in lithographic microfabrication and MEMS. Experience with MEMS for biosensing applications or cell mechanics measurement is a plus. Applicants should be assertive, self-driven researchers who have a strong publication record from their PhD and/or previous post-doctoral positions.
Compensation: \$48,000 per year with university benefits.

Applicants should apply via email to Prof. Hoelzle (hoelzle.1@osu.edu). Please supply a current CV, anticipated start date, and the contact information for three references.

The Ohio State University is an equal opportunity employer. All qualified applicants will receive consideration for employment without regard to race, color, religion, sex, sexual orientation, gender identity, national origin, disability status, or protected veteran status.